RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITED PROCEDURE - EXAMINING GROUP 2800**

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Vishnu K. Agarwal

Attorney Docket No.: 501082.02 (98-06)

Serial No. : 09/652,994

Group Art Unit

: 2815

Filed

: August 31, 2000

Examiner

: Jesse A. Fent

Title

: DEVICE AND METHOD FOR PROTECTING AGAINST OXIDATION

CONDUCTIVE LAYER IN SAID DEVICE

Box AF Commissioner of Patents Washington, DC 20231

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

Please amend the above-captioned patent application as follows:

In the Specification:

Please replace the paragraph beginning at page 8, line 4, with the following rewritten paragraph:

--Still other gases include diborane (B₂H₆); phosphine (PH₃); and carbon-silicon compounds such as methylsilane (CH₃SiH₃) and hexamethyldisilane (CH₃)₃Si-Si(CH₃)₃; and hexamethyldisilazane (HMDS). Additional alternate embodiments of the current invention use hydrazine (N₂H₄), monomethylhydrazine, carbon tetrafluoride (CF₄), CHF₃, HCl, and boron trichloride (BCl₃), which are also useful in passivating dielectrics, as addressed in copending

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